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DLS:lam 04/06/01 44987.doc Attorney Reference Number 4641-58305 PATENT EXPRESS MAIL LABEL NO. EL696107308US DATE OF DEPOSIT: April 6, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

BOX PATENT APPLICATION COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231



Transmitted herewith for filing is the patent application of:

Inventor(s): Shigeru Nakayama, Yuichi Takigawa and Takashi Gemma

For: APPARATUS AND METHODS FOR MEASURING SURFACE PROFILES AND WAVEFRONT ABERRATIONS, AND LENS SYSTEMS COMPRISING SAME

Enclosed are:

23 pages of specification, 12 pages of claims, an abstract and a Combined Declaration and Power of Attorney (unsigned).

9 sheet(s) of drawings.

Request for Non-publication and Certification under 35 U.S.C. § 122(b)(2)(B)(i).

	FILING FEE					
	Claims	Number		Number		Basic Fee
For	Filed	Free		Extra	Rate	\$710.00
Total Claims	63	20	=	43	\$18.00	\$774.00
Independent Claims	6	3	=	3	\$80.00	\$240.00
Multiple Dependent Claim Fee \$270.00					\$270.00	
TOTAL FILING FEE						\$1724.00

Applicants claim the benefit under 35 U.S.C. § 119 of the earlier filing dates of Japan Application No. 2000-105156, filed on April 6, 2000, and Japan Application No. 2001-079,695 filed on March 21, 2001.

Assignee for this application is or will be Nikon Corporation, and applicants request that this information be listed on the published application.

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Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

KLARQUIST SPARKMAN CAMPBELL LEIGH & WHINSTON, LLP

By

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cc: Docketing

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